

Physics of Low Temperature/Non-Equilibrium Plasmas

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June 14th 2023, SULI Introduction to Fusion Energy and Plasma Physics Course



UNIVERSITY OF MINNESOTA

Driven to Discover®

About me

Yaoundé, Cameroon: Up to end of high school France (Troyes and Paris): Undergrad and Grad Studies



Up to 2006

**THE Ohio State
University: Postdoc**

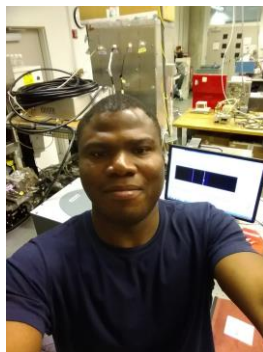


2015-2018



2006-2015

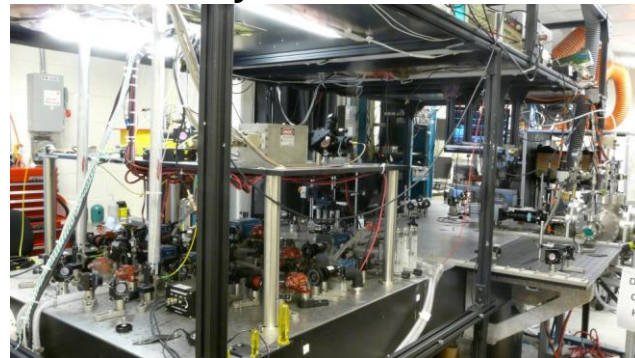
**University of Minnesota:
Research Associate**



2018-2020



**PPPL: Associate Research
Physicist**



2020-2022



The Laboratory for Plasma Soft X-Ray Light Sources and Diagnostics (1)

- Development of ultrafast coherent (laser-based) spectroscopic diagnostics of plasmas and high speed flows
- Development and characterization of plasma-based soft x-ray extreme ultraviolet lithography light sources



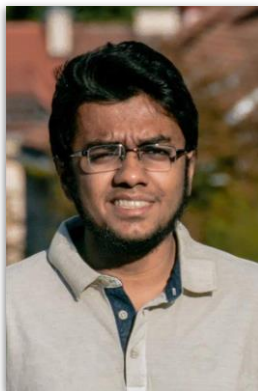
Marien Simeni

P.I.



Ji Yung Ahn

EUV Lithography



Tasnim Akbar Faruquee

EUV Lithography



Grayson LaCombe

Ultrafast coherent diagnostics

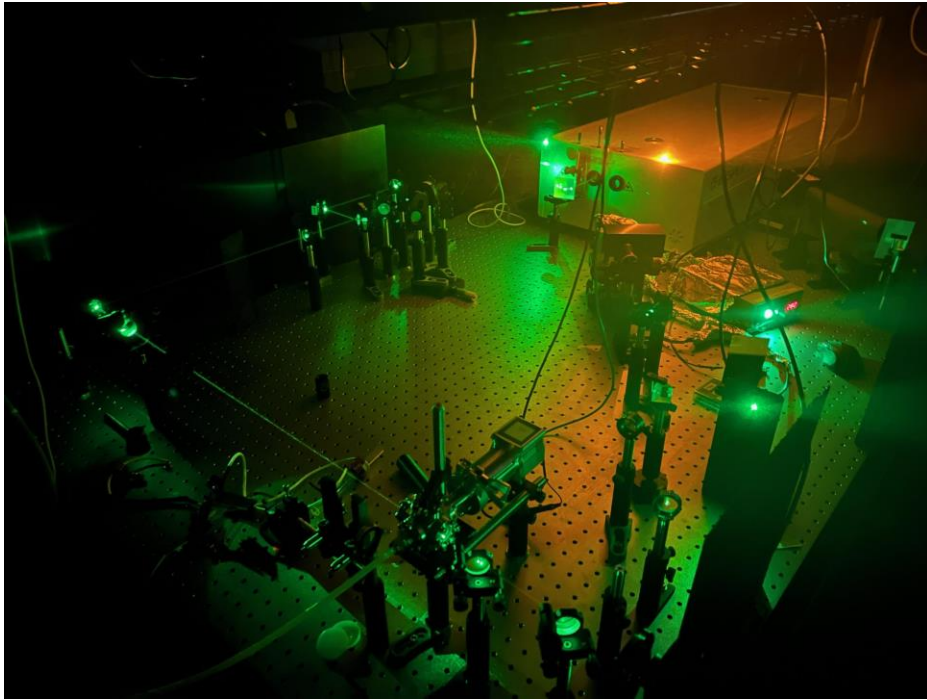


Dr. Jianan Wang

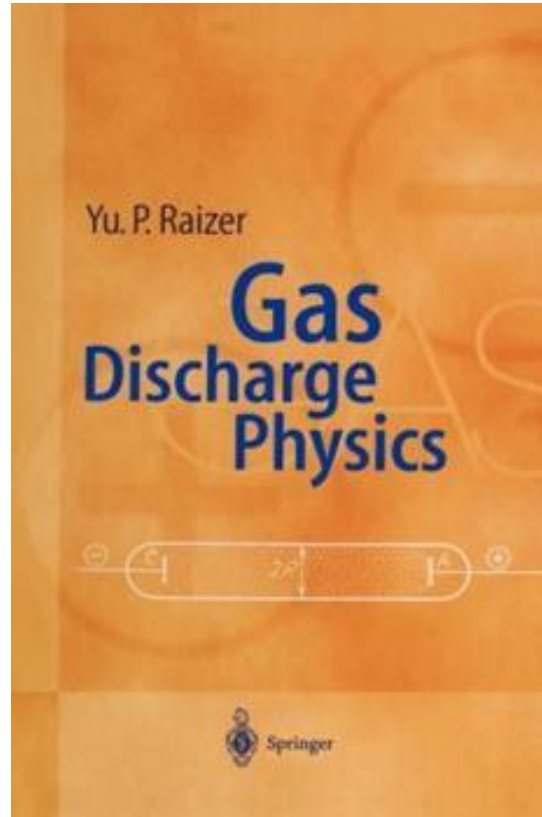
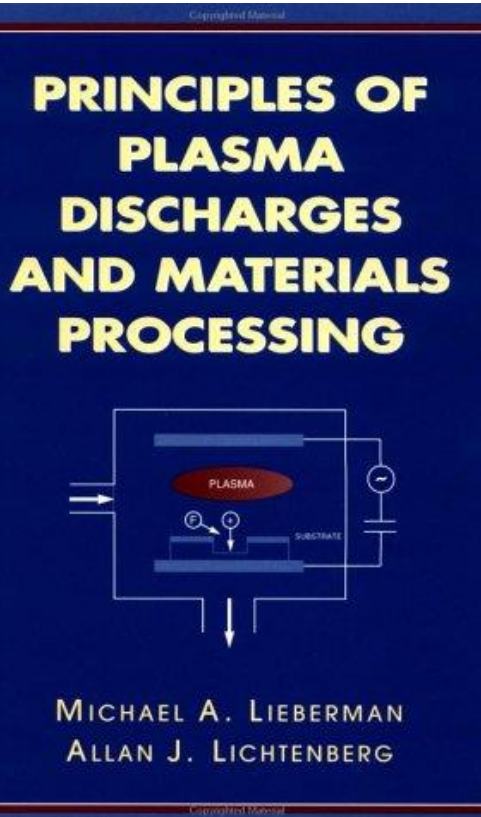
EUV Lithography/
Ultrafast coherent
diagnostics



The Laboratory for Plasma Soft X-Ray Light Sources and Diagnostics (2)



Some Good References



OPEN ACCESS

IOP Publishing

J. Phys. D: Appl. Phys. 55 (2022) 373001 (55pp)

Journal of Physics D: Applied Physics

<https://doi.org/10.1088/1361-6463/ac5e1c>

Roadmap

The 2022 Plasma Roadmap: low temperature plasma science and technology

I Adamovich¹, S Agarwal², E Ahedo³, L L Alves⁴, S Baalrud⁵, N Babaeva⁶, A Bogaerts⁷, A Bourdon⁸, P J Bruggeman^{9,*}, C Canal¹⁰, E H Choi¹¹, S Coulombe¹², Z Donko¹³, D B Graves^{14,15}, S Hamaguchi¹⁶, D Hegemann¹⁷, M Hori¹⁸, H-H Kim¹⁹, G M W Kroesen²⁰, M J Kushner²¹, A Laricchiuta²², X Li²³, T E Magin²⁴, S Mededovic Thagard²⁵, V Miller²⁶, A B Murphy²⁷, G S Oehrlein²⁸, N Puac²⁹, R M Sankaran³⁰, S Samukawa³¹, M Shiratani³², M Šimek³³, N Tarasenko³⁴, K Terashima³⁵, E Thomas Jr³⁶, J Trieschmann³⁷, S Tsikata³⁸, M M Turner³⁹, I J van der Walt⁴⁰, M C M van de Sanden^{20,41} and T von Woedtke^{42,43}

IOP Publishing

Plasma Sources Sci. Technol. 26 (2017) 123002 (17pp)

Plasma Sources Science and Technology

<https://doi.org/10.1088/1361-6595/aa97af>

Topical Review

Foundations of atmospheric pressure non-equilibrium plasmas

Peter J Bruggeman¹, Felipe Iza² and Ronny Brandenburg³

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² Wolfson School of Mechanical, Electrical and Manufacturing Engineering, Loughborough University, Loughborough LE11 3TU, United Kingdom

³ Leibniz Institute for Plasma Science and Technology (INP Greifswald), Felix-Hausdorff-Strasse 2, D-17489 Greifswald, Germany



Outline

- ✓ **Low Temperature Plasmas and Applications**
- ✓ **Generation of Low Temperature Plasmas and Basic Properties**
- ✓ **Energy Partition and Transfer in Low Temperature Plasmas**
- ✓ **Case Study #1: Plasma-Assisted Ignition**
- ✓ **Case Study #2: Inactivation of Viruses and Bacteria**
- ✓ **Case Study #3: Polymer Etching**
- ✓ **Extra: Atmospheric Reentry**
- ✓ **Conclusion**



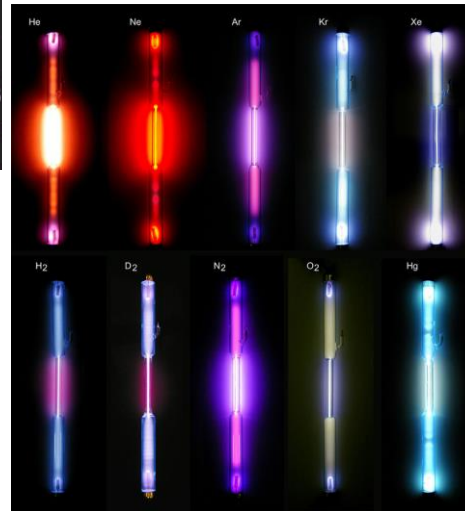
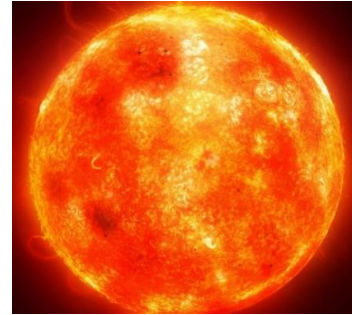
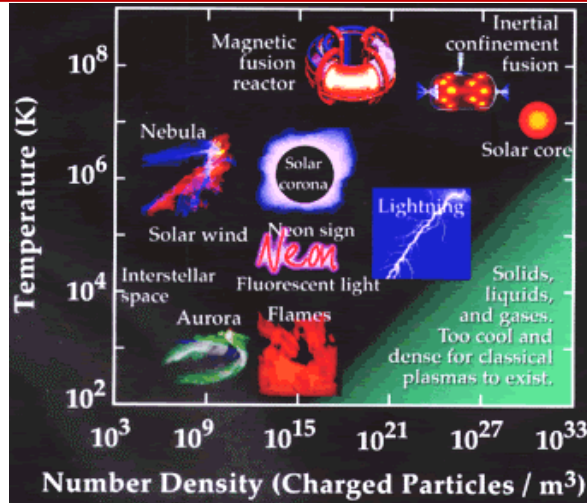
Low Temperature Plasmas and Applications





Plasmas?

- Ionized gases
- 4th state of matter
- 99.9% of the visible universe
- Made of neutral particles, free electrons, ions, electric fields, photons
- Span over several orders of magnitude of densities and temperatures

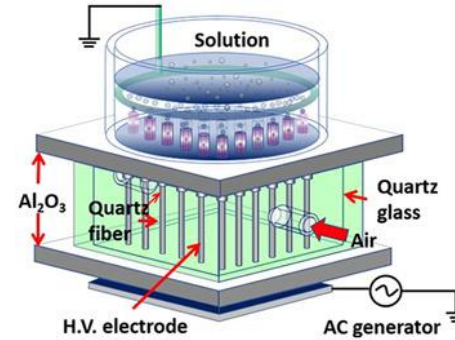
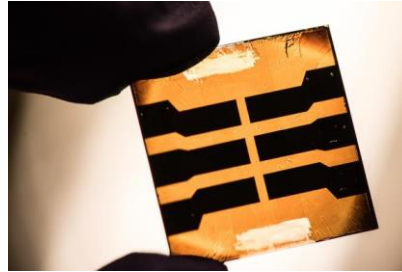


Current Grand Challenges of Engineering

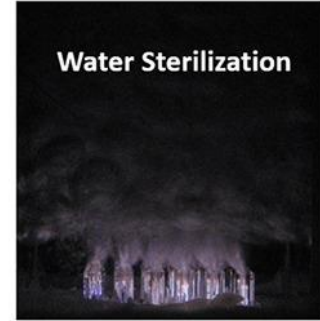
US Academy of Engineering

- Make solar energy economical
- Provide access to clean water
- Provide energy from fusion
- Manage the nitrogen cycle
- Engineer the tools for scientific discovery
- Improve CO₂ sequestration

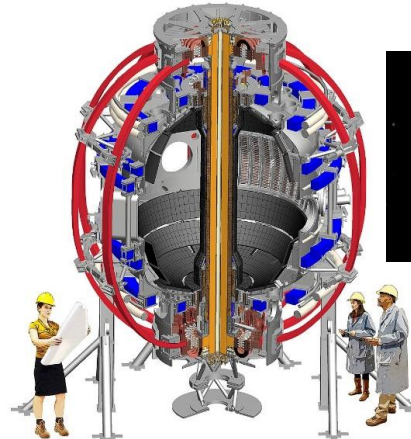
Perovskite solar cell



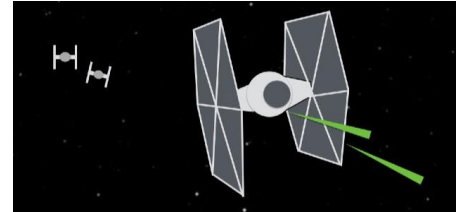
Water Sterilization



Spherical Tokamak at PPPL



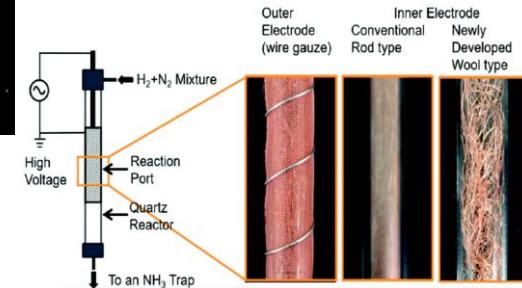
Electric propulsion for spacecraft



Star Wars twin ion engine fighters

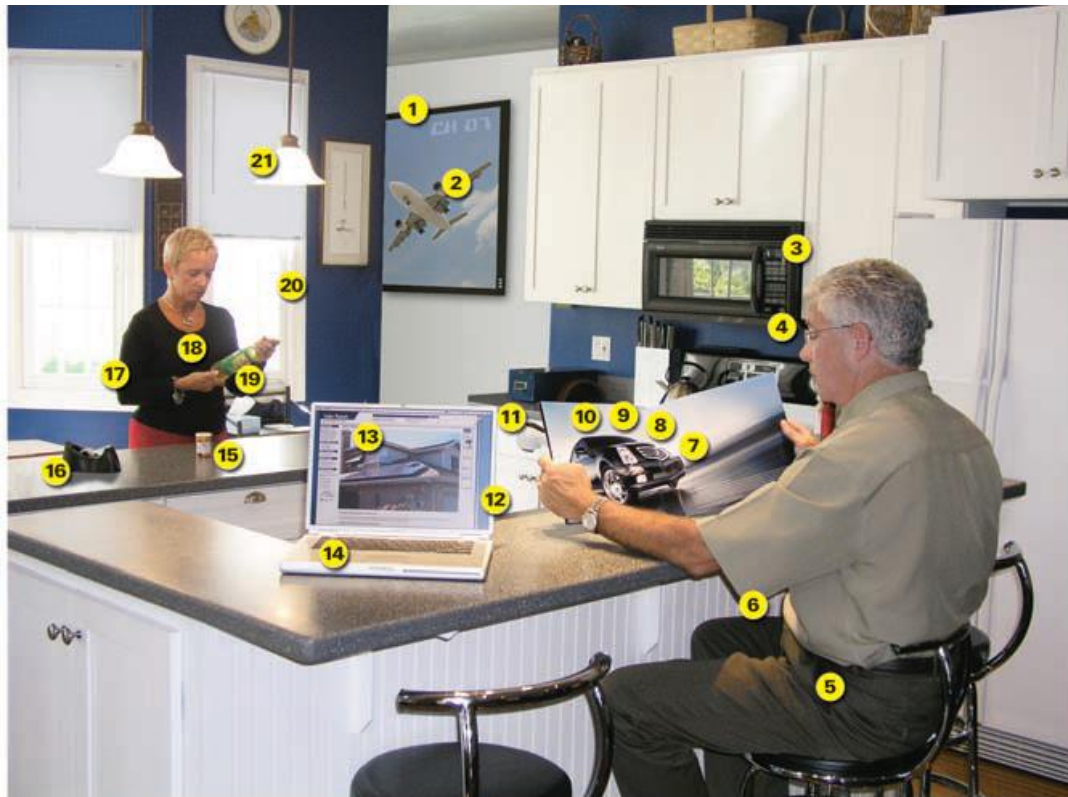
Aihara et al. ChemComm(2016)

Plasma-assisted ammonia synthesis



Zhang et al. ACS Plasma Proc Polym (2018)

LT Plasmas Impact our Every-day Life

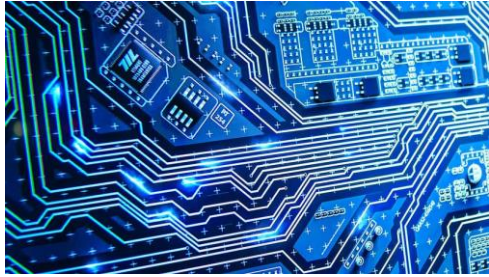


- 01 — Plasma TV
- 02 — Plasma-coated jet turbine blades
- 03 — Plasma-manufactured LEDs in panel
- 04 — Diamond-like plasma CVD eyeglass coating
- 05 — Plasma ion-implanted artificial hip
- 06 — Plasma laser-cut cloth
- 07 — Plasma HID headlamps
- 08 — Plasma-produced H₂ in fuel cell
- 09 — Plasma-aided combustion
- 10 — Plasma muffler
- 11 — Plasma ozone water purification
- 12 — Plasma-deposited LCD screen
- 13 — Plasma-deposited silicon for solar cells
- 14 — Plasma-processed microelectronic
- 15 — Plasma-sterilization in pharmaceutical production
- 16 — Plasma-treated polymers
- 17 — Plasma-treated textiles
- 18 — Plasma-treated heart stent
- 19 — Plasma-deposited diffusion barriers for containers
- 20 — Plasma-sputtered window glazing
- 21 — Compact fluorescent plasma lamp

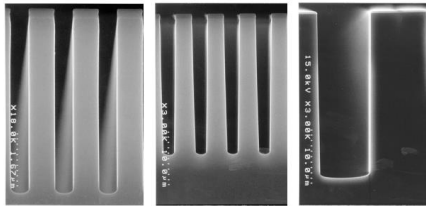
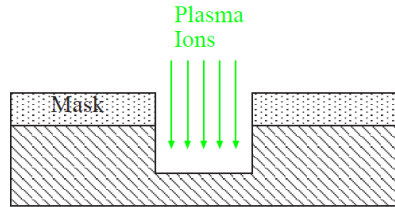
Plasma Science: Advancing Knowledge in the National Interest, National Research Council (US, 2007)



The Semiconductor Success Story



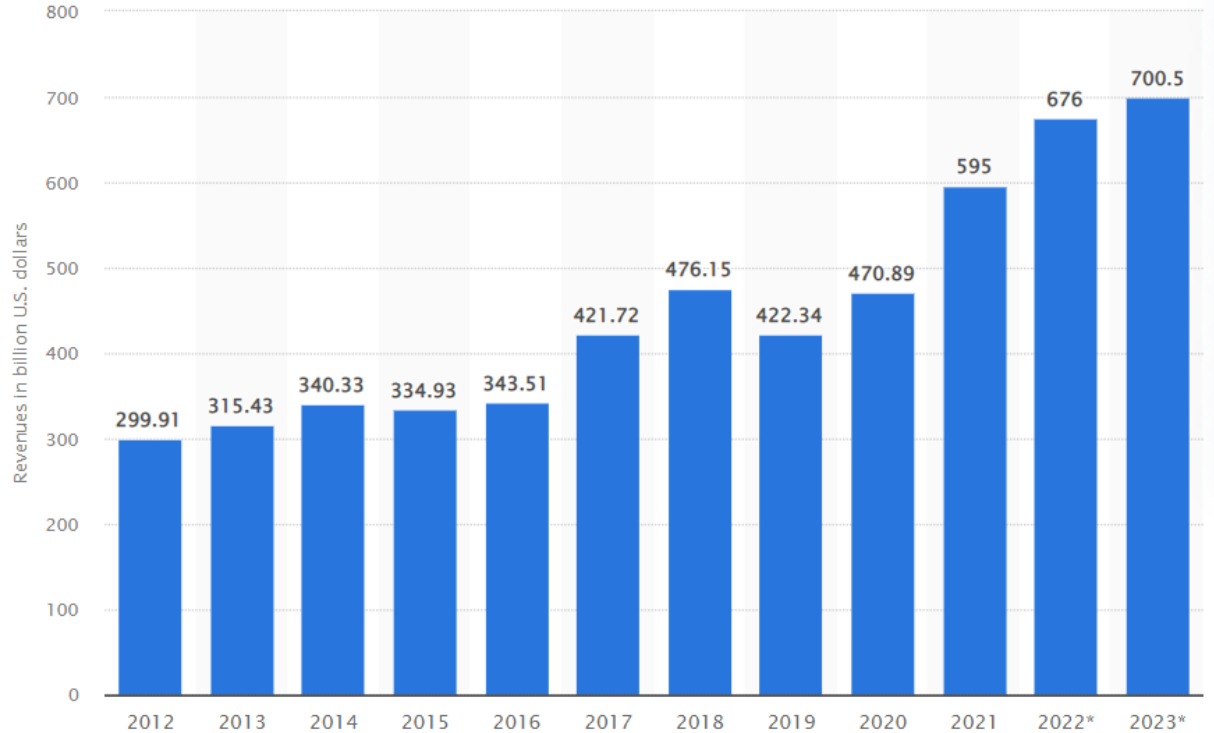
Anisotropic Plasma Etching



CD = 0.6µm
Trench Depth = 5.6µm
E/R = 1.9µm/min.

CD = 3µm
Trench Depth = 26µm
E/R = 3.2µm/min.

CD = 10µm
Trench Depth = 31µm
E/R = 3.9µm/min.



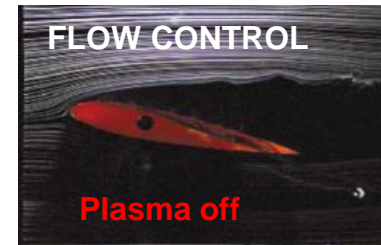
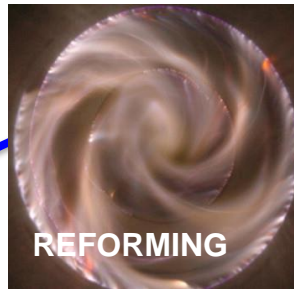
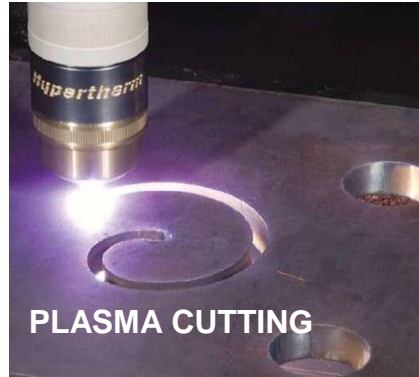
Wu et al, J. Appl. Phys. 108, 051101 (2010)



Plasmas and Applications: Thermal VS Non-Thermal

Thermal plasmas:

$$T_g \sim T_e (2,000 - 10,000 \text{ K})$$



Non-thermal plasmas:
 $T_g \ll T_e (10,000 \text{ K})$



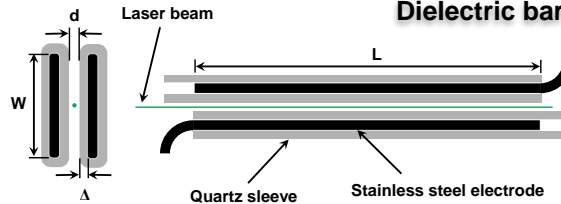
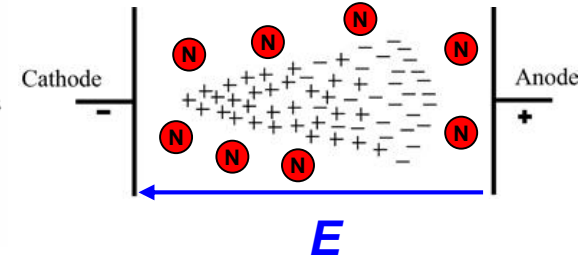
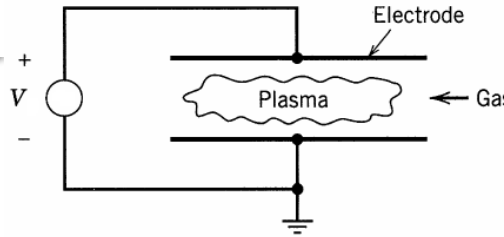
Generation of LT Plasmas and Basic Properties



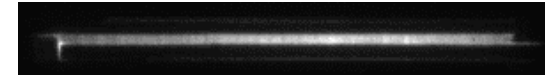
Gas Discharges as Low Temperature Plasmas

We use electric fields instead of heat!

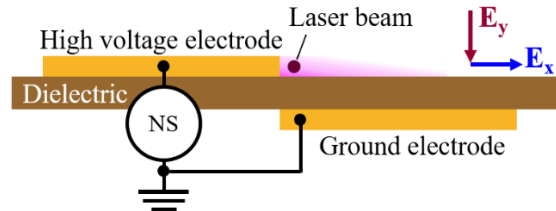
- Electrically driven
- Different excitation sources can be employed: DC, AC, RF, Microwave, nanosecond pulsed,...
- The source of energy is the E-field
- High E-fields lead to ionizing collisions
- Charged particles collisions with neutrals cause the main energy transfer from the electric field energy to the gas
- When the energy transfer of electrons to neutral particles is not very fast, the energy of electrons ($=T_e$) can be significant larger than the neutral particles energy ($=T_g$): $T_g \ll T_e$



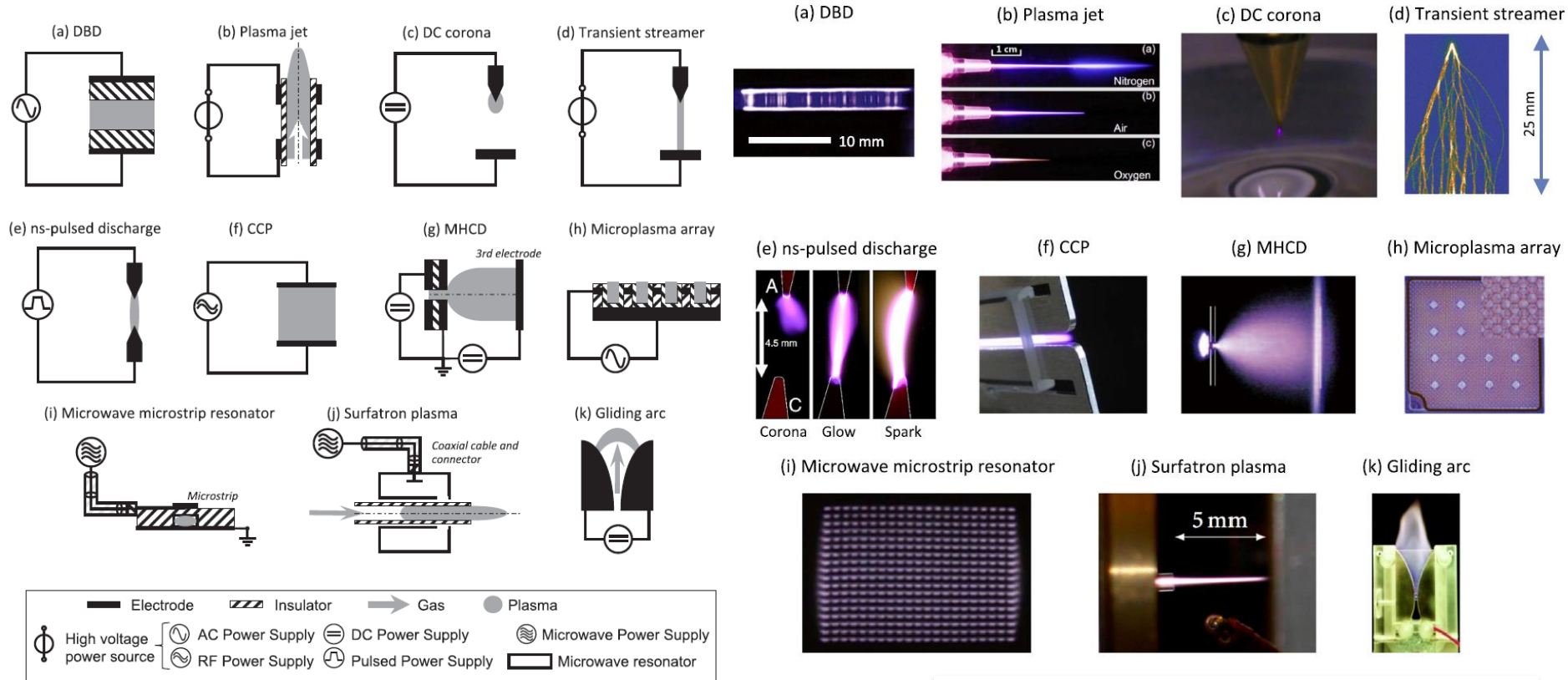
Dielectric barrier discharge



Surface dielectric barrier discharge



Overview of Atmospheric Pressure LT Plasmas



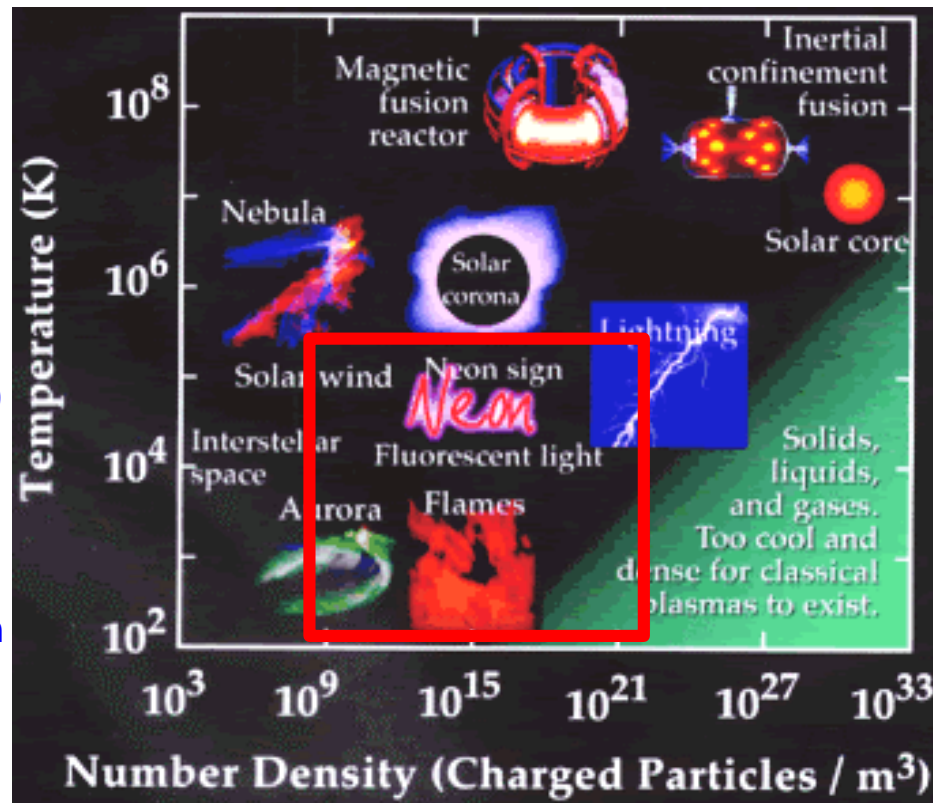
Bruggeman et al, Plasma Sources Sci. Technol. 26 (2017) 123002



LT Plasmas are Rich of Physics and Chemistry

- Span over 12 orders of magnitude for n_e
- Often low ionization fraction (degree): $\frac{n_e}{N} < 1\%$
- Ions and neutrals temperatures are near room temperature: $T_i \sim T_g \sim \frac{1}{40} \text{ eV}$
- Electron temperature can reach several eV: $T_e \sim 1\text{-}10 \text{ eV}$
- **Highly non-equilibrium**
- Highly reactive plasmas can be generated near room gas temperatures
- In presence of molecular gases, dissociation can occur generating a very rich and complex electrons-driven chemistry: **LT plasma = chemical processor**

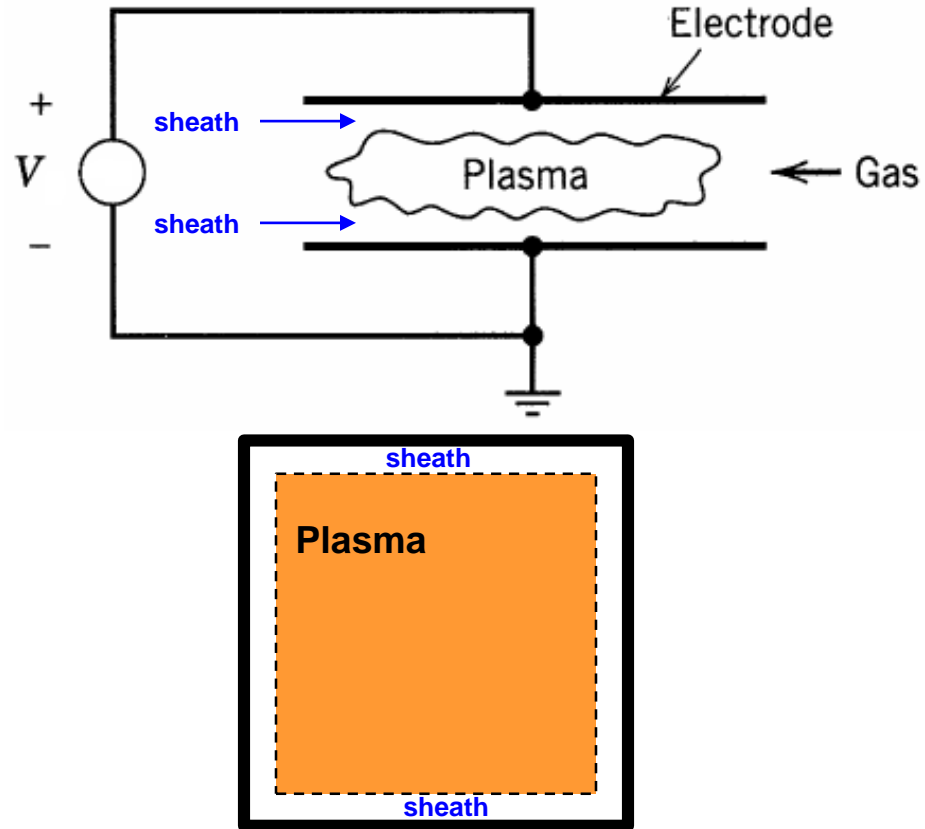
1 eV \approx 11,606K



Plasma Interactions with Surfaces: Formation of Sheaths

Plasma are surrounded by Sheaths!

- The sheath is the boundary layer between a plasma and a solid surface (electrodes, substrate, container walls, ...)
- It acts to balance electron and ion currents lost from a plasma
- Sheaths are characterized by a strong E-field, low electron density
- Sheaths form as ions are accelerated into surfaces
- Sheaths have an important role for applications relevant to: removal of surface material and ion implantation



Sheaths size depends on the plasma density (pressure)

The Debye length is the characteristic length scale of a plasma

- It's the distance scale over which significant charge densities can spontaneously exist

Using Poisson's equation:

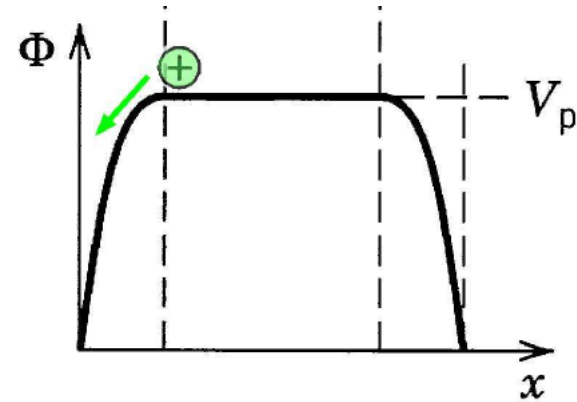
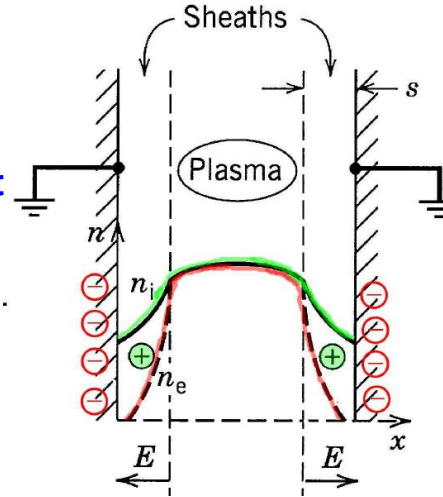
$$\phi = \phi_0 e^{-|x|/\lambda_{De}} \quad \lambda_{De} = \left(\frac{\epsilon_0 T_e}{en_e} \right)^{\frac{1}{2}}$$

$$\lambda_{De}(cm) = 740 \sqrt{T_e/n_e} \quad T_e \text{ in eV and } n_e \text{ in cm}^{-3}$$

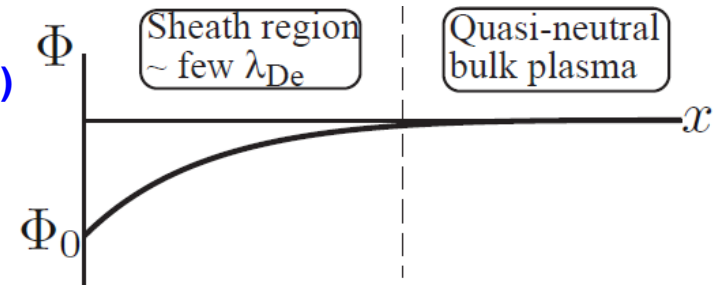
- For $T_e = 4 \text{ eV}$ and $n_e = 10^{10} \text{ cm}^{-3}$, $\lambda_{De} \sim 148 \text{ } \mu\text{m}$ (quite small!)

- Sheath thickness l_s provided by Child-Langmuir sheath model:

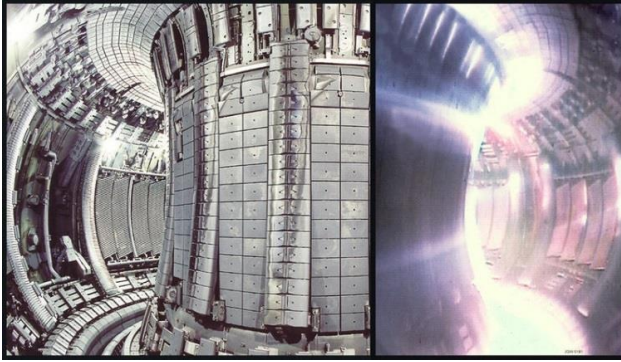
$$\frac{l_s}{\lambda_{De}} = \frac{\sqrt{2}}{3} \left(\frac{2e\Delta\phi}{T_e} \right)^{3/4}$$



$$\mathbf{E} = -\nabla\phi$$



Comparison between Hot and Cold Plasmas



EFDA JET: Joint European Torus



| | JET Tokamak | Atmospheric pressure plasmas |
|----------------------|---|--|
| Power | ~ 16 MW | $10^{-2} - 10$ W |
| Volume | ~ 100 m ³ | $\sim 10^{-8}$ m ³ (10 mm ³) |
| Power density | 10^6 W m⁻³ | 10^6-10^9 Wm⁻³ |
| Ionization degree | FULL | $10^{-5} - 10^{-2}$ |
| Temperature | $T_e = T_g = 10^8$ K | $T_e = 10^3$ - 10^4 K $T_g = 300 - 3000$ K |
| Pulse duration | ~ 1 s | ~ 10 ns up to DC |

Courtesy of
Peter
Bruggeman,
University of
Minnesota



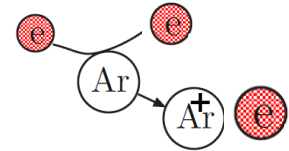
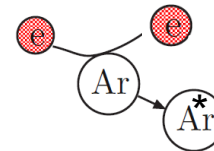
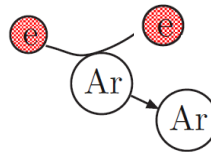
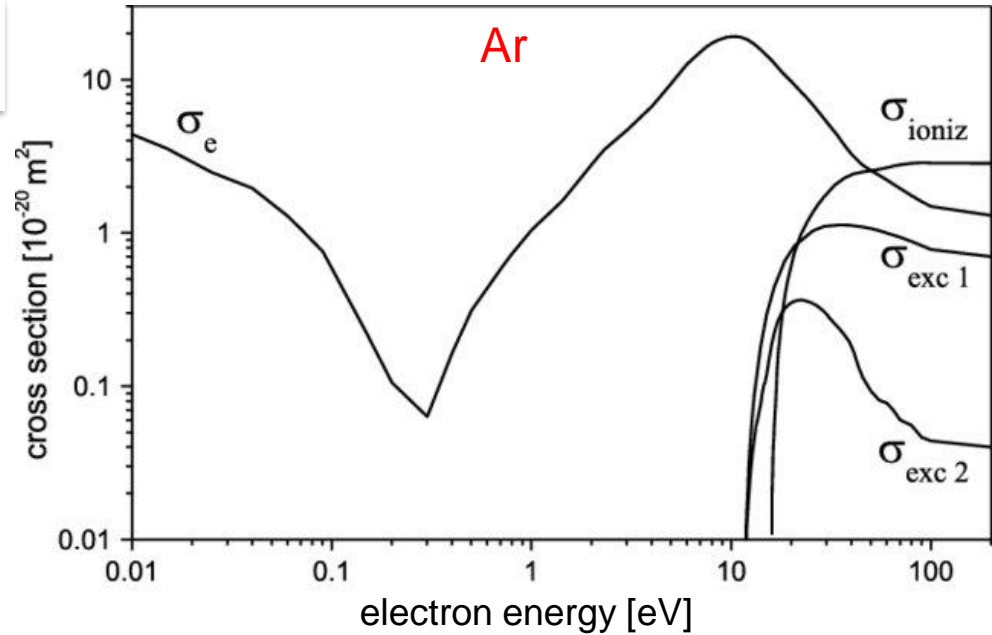
Energy Partition and Transfer in LT Plasmas



Collisions and Elementary Reactions: Atomic Gas

We use cross sections to quantify the probability that a process may occur

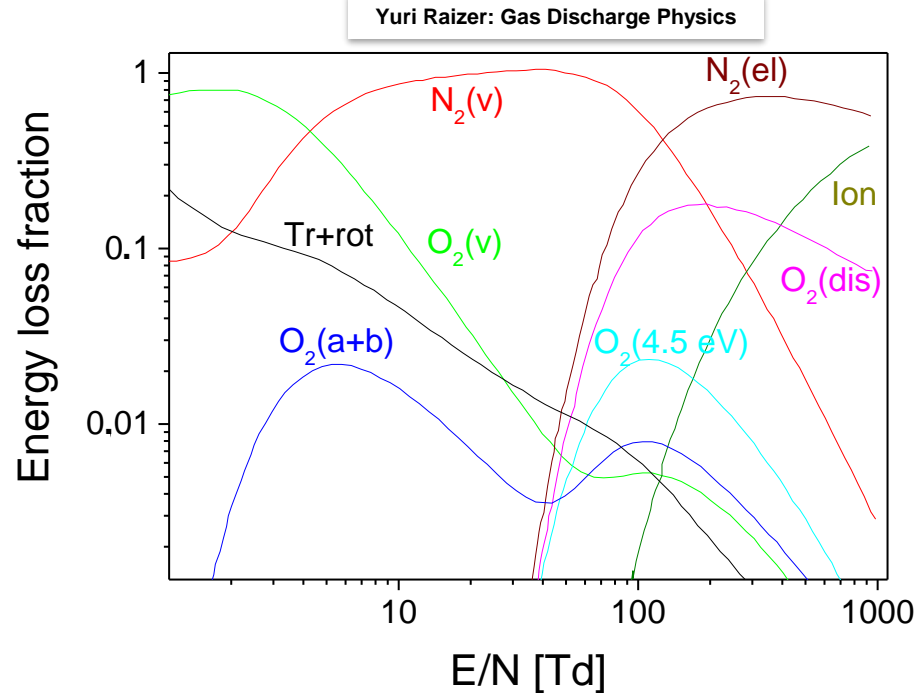
- **Elastic collisions:** $e^- + \text{Ar} \rightarrow \text{Ar} + e^-$
- **Electronic excitation collisions:** $e^- + \text{Ar} \rightarrow \text{Ar}^* + e^- \rightarrow \text{Ar} + e^- + \text{photons}$
- **Ionizing collisions:** $e^- + \text{Ar} \rightarrow \text{Ar}^+ + e^- + e^-$
- **Cross sections from different databases are compiled on the LXCAT website:**
<https://us.lxcat.net/>
- **Databases:** IST-Lisbon, Morgan, Phelps, Itikawa, Trinit, Hayashi, ...
- **1 eV $\sim 1.6 \times 10^{-19}$ J**



Energy Partition in a Molecular Gas: Air

Where does the energy from the electrons go?

- E/N , electric field divided by total number density
- 1 Td (Townsend) = 10^{-17} V.cm²
- The rates of electron impact processes depend exponentially on E/N
- At low E/N values (< 10 Td): Energy coupled preferentially to vibrational excitation of O_2
- For $10 \text{ Td} < E/N < 100 \text{ Td}$: Energy coupled preferentially to vibrational excitation of N_2
- For $E/N > 100 \text{ Td}$: Energy coupled into electronic excitation of N_2 , O_2 dissociation and ionization



High E/N values result in high reactivity and rapid electron-driven processes. This is for instance achieved using nanosecond pulsed discharges



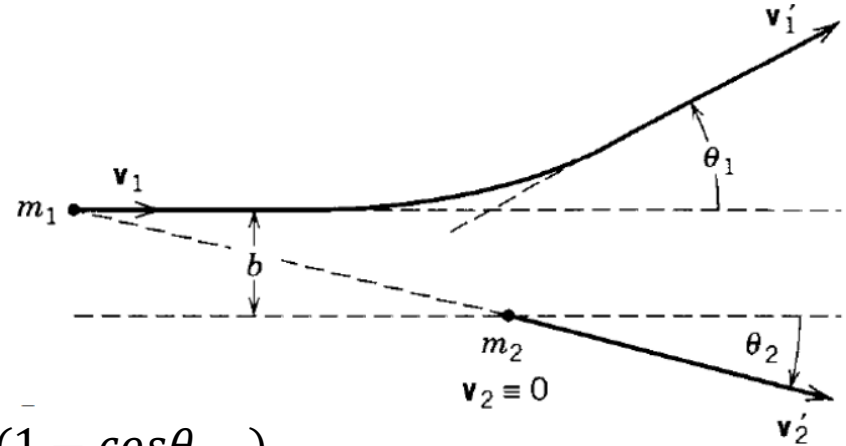
Energy Transfer in an Elastic Collision (1)

- Expressing energy and momentum balances yields:

W_L = final energy for particle m_2
 W = initial energy for particle m_1

$$\frac{W_L}{W} = \zeta_L = \frac{4m_1m_2}{(m_1 + m_2)^2} \cos^2 \theta_2 = \frac{2m_1m_2}{(m_1 + m_2)^2} (1 - \cos \theta_{CM})$$

$$\theta_2 = \frac{\pi}{2} - \frac{\theta_{CM}}{2}$$



CM = Center of Mass (given)

- What is now the average energy transfer per collision?



Energy Transfer in an Elastic Collision (2)

Fraction of energy transferred in one collision:

- For electron – neutral collision (hard sphere model)

$$\frac{2m_1m_2}{(m_1 + m_2)^2} \approx \frac{2m_e}{M} \approx 10^{-4}$$

Electrons transfer little energy in elastic collisions with neutrals: $T_e \gg T_g$

- For ion – neutral collision (with same mass)

$$\frac{2m_1m_2}{(m_1 + m_2)^2} = \frac{1}{2}$$

Equilibration rates depend on the mass ratios

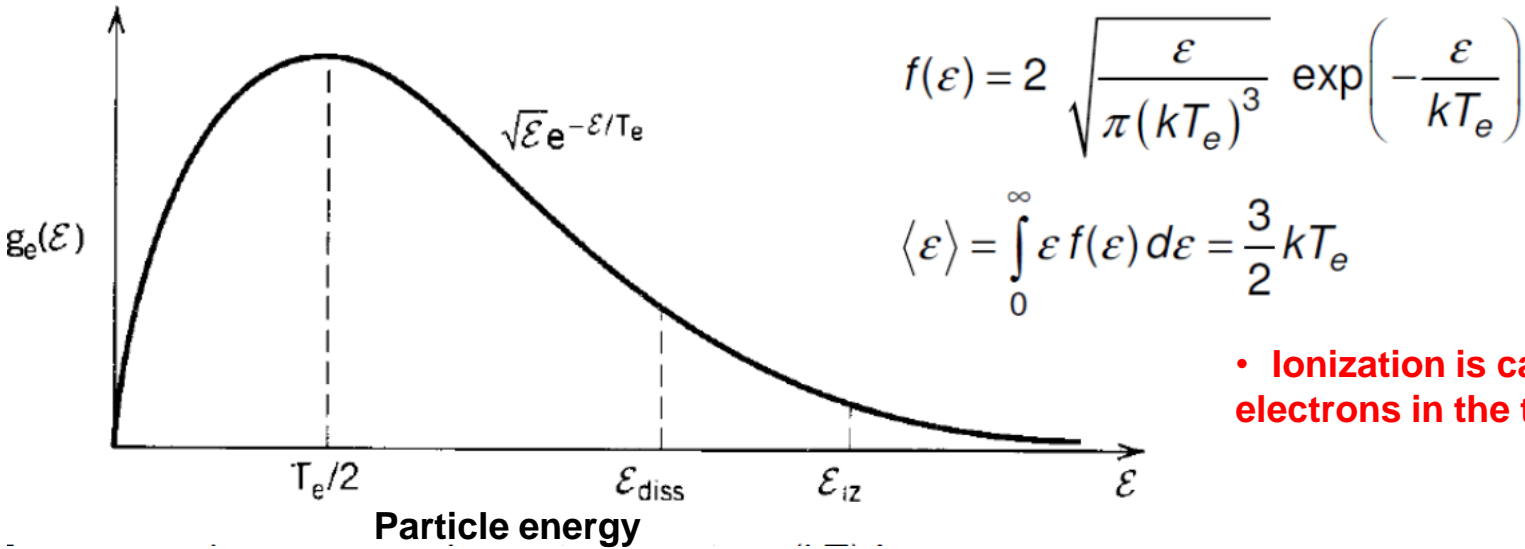
Ions neutral collisions transfer significant energy in elastic collisions: $T_{\text{ion}} \sim T_g$



What does Temperature mean?

Temperature is actually related to the mean kinetic energy!

Concept of thermal equilibrium in statistical mechanics: Maxwell-Boltzmann distribution function of the particle energy

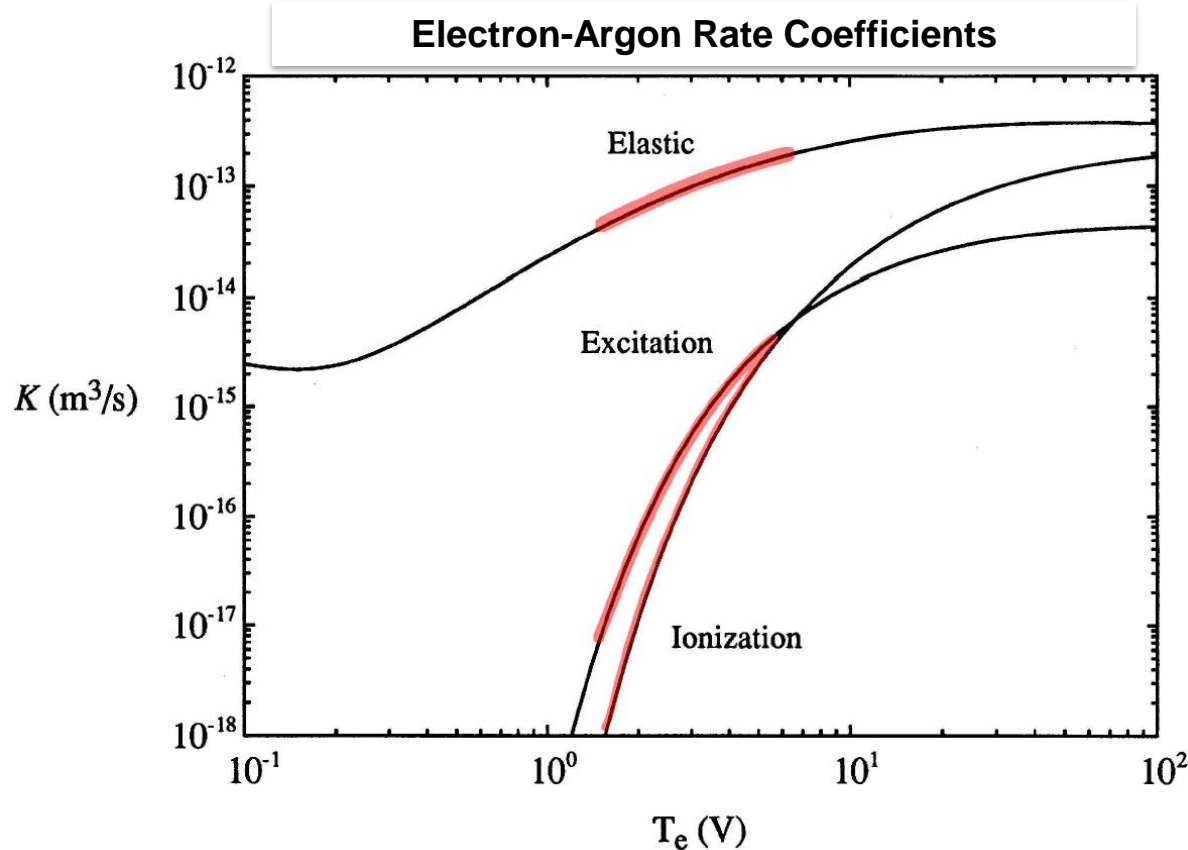


• Ionization is caused by high energy electrons in the tail of the distribution!

- An electron temperature (T_e) of 1 eV therefore means that the plasma has an electron energy distribution function (EEDF) with a mean energy of 3/2 eV



Rate Coefficients



- Rate coefficient is the average of the cross section $\sigma(V_R)$ of the process over the Maxwellian distribution
- $K(T_e) = \langle \sigma V_R \rangle_{\text{Maxwellian}}$
- V_R = relative velocity of colliding particles
- The knowledge of rate coefficients is indispensable for establishing accurate collisional-radiative models of plasmas

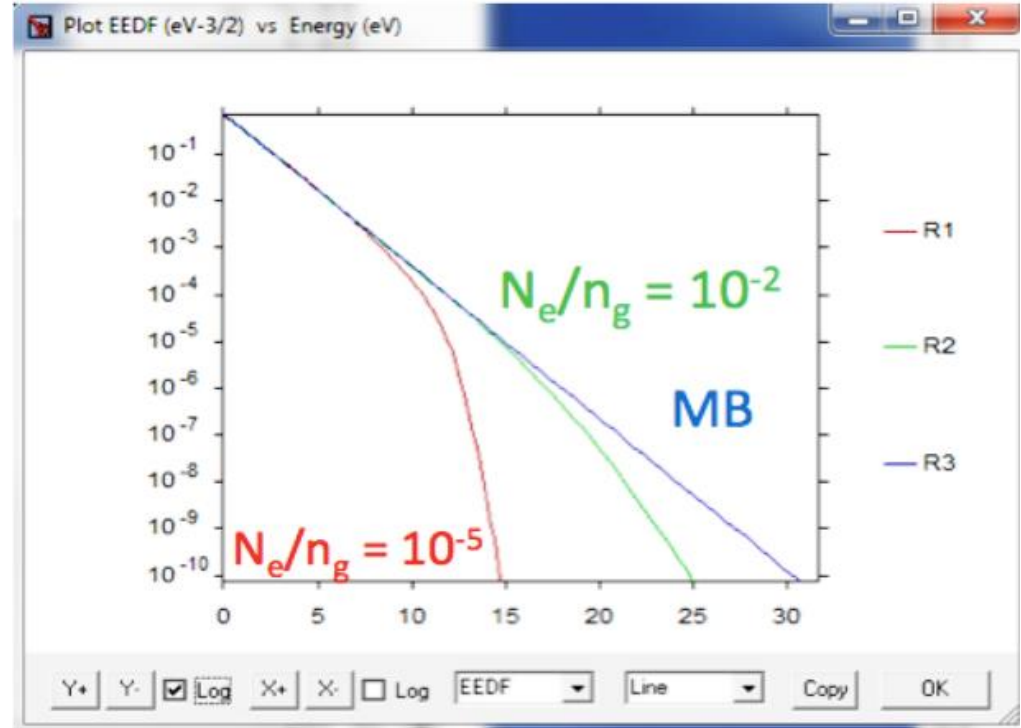


Deviation from Maxwell-Boltzmann Distribution

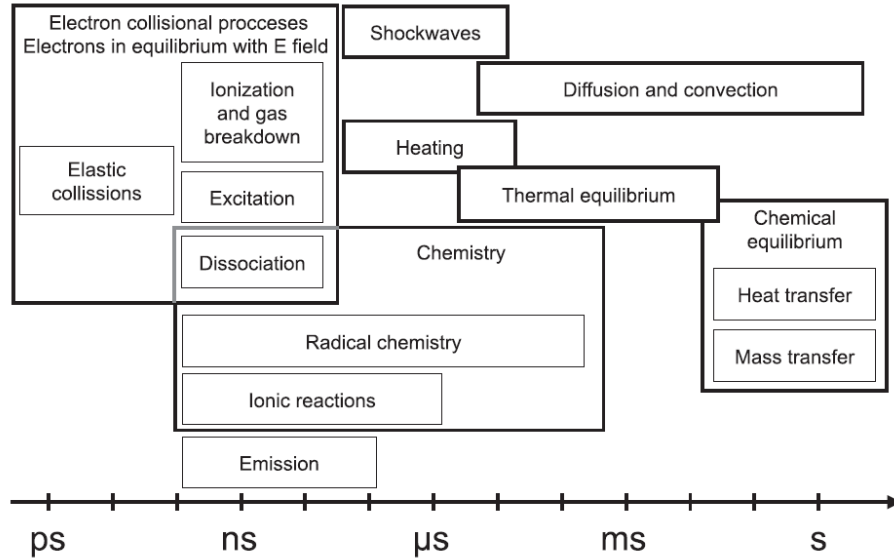
The EEDF is not necessarily Maxwell-Boltzmann!

- It depends on the ionization degree
- Assuming M-B when it is not can hugely impact rates with high threshold energy
- Plasma codes have a Boltzmann solver (EEDF can depend on gas composition)

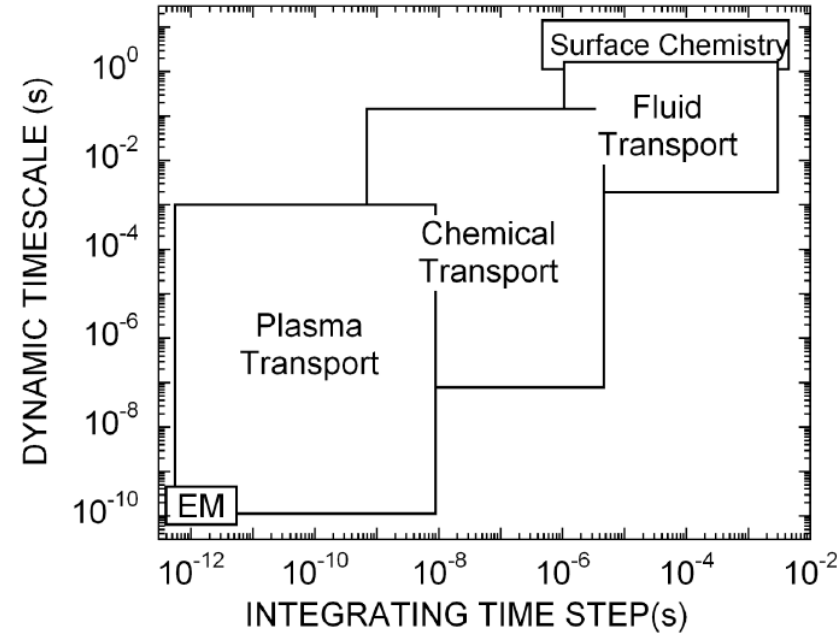
Bolsig+: Boltzmann equation solver



LT Plasmas Modeling and Timescales



- About 12 orders of magnitude in timescales
- Integrating time step (stability, accuracy): Δt
- Dynamic timescale (to resolve the evolution of plasma phenomena): ΔT



Mark J. Kushner, University of Michigan

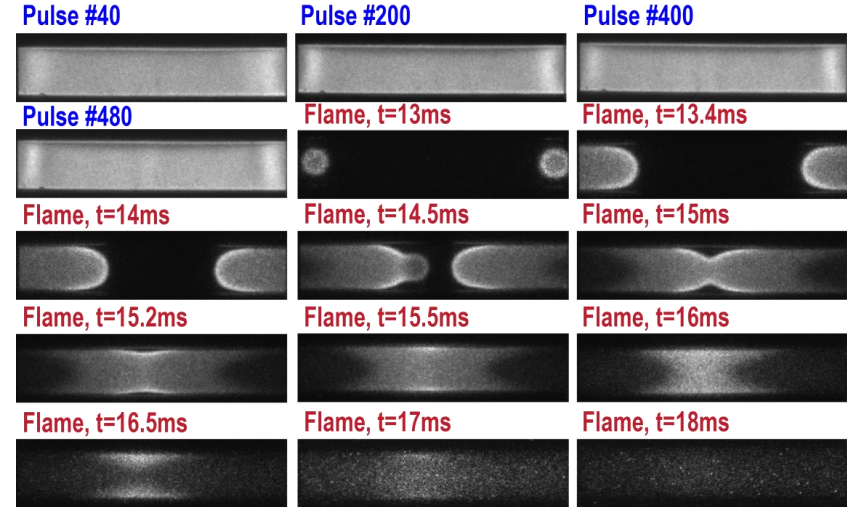
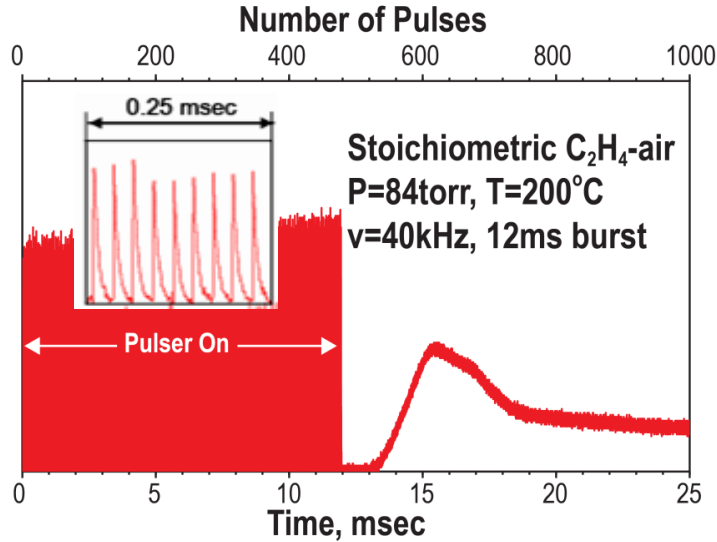
Bruggeman et al, Plasma Sources Sci. Technol. 26 (2017) 123002



Case Study #1: Plasma-Assisted Ignition



C_2H_4 Ignition below Autoignition Temperature



OH emission from plasma and flame

- Ignition induced by radicals generated in the plasma (primarily O and H atoms)
- Ignition occurs at temperature ≈ 200 K below autoignition
- Ignition begins near edges of the plasma (higher energy loading)
- Flame propagates to the center of the plasma

Yin et al, IEEE Trans Plasma Sci. 2011

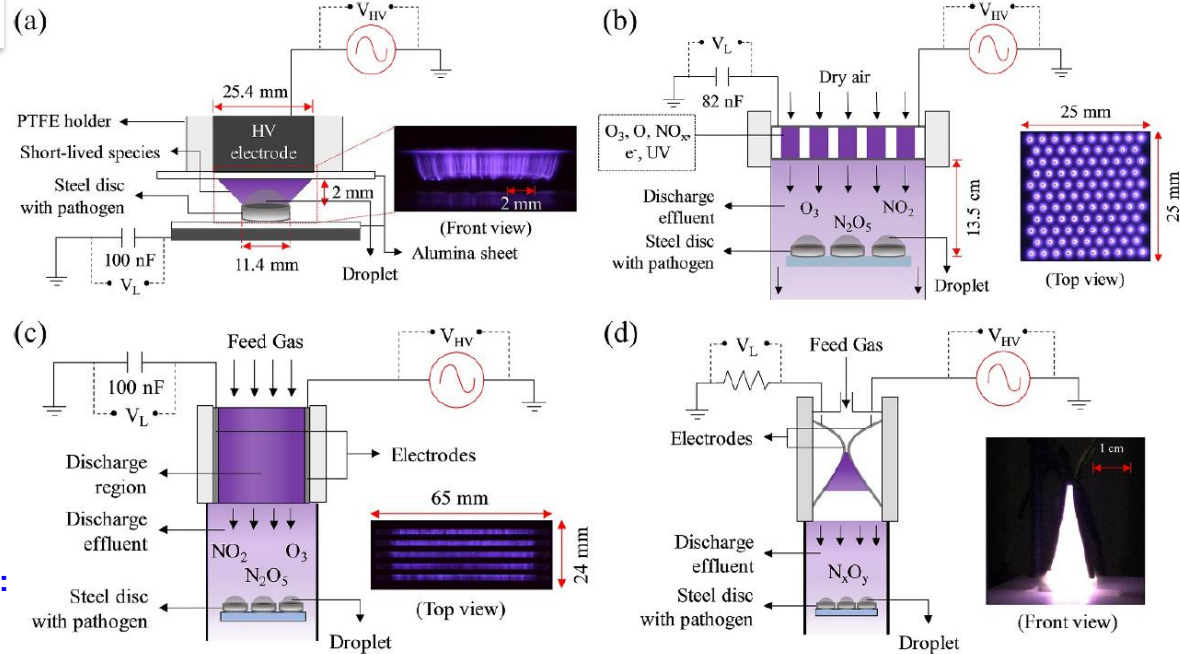
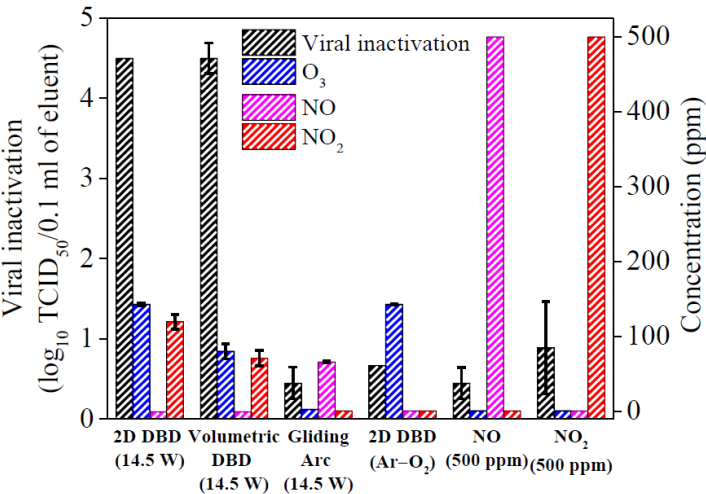


Case Study #2: Inactivation of Viruses and Bacteria



RONs from Air Plasmas for Virus Inactivation

RONs = Reactive Oxygen Nitrogen Species



FCV = Feline CaliciVirus (surrogate of human norovirus = stomach flu)

- **Reactive components from plasma chemistry:** O_3 , NO_x , OH , O , H_2O_2 , N_2^+ , O_2^+ , O_2^- , UV light, e^-
- **Comparison of surface decontamination efficiency of 4 different plasmas**
- **Strong correlations between generation of gas phase N_2O_5 and inactivation**

Moldgy et al, J. Phys. D: Appl. Phys. 53 (2020) 434004



Case Study #3: Polymer Etching



Etching from O, H, OH Produced by a RF Plasma Jet

- Etching of polystyrene, PMMA (poly methyl methacrylate) and PVA (poly vinyl alcohol)
- Ar+1% O₂, Ar+1% air, Ar +1% H₂O plasma jets
- Correlation between O flux at the surface and polymer etching rate
- Etching probability of polystyrene by OH at least one order of magnitude greater than etching of polystyrene by O radicals

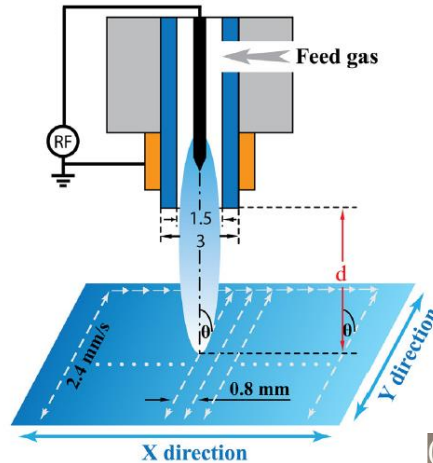
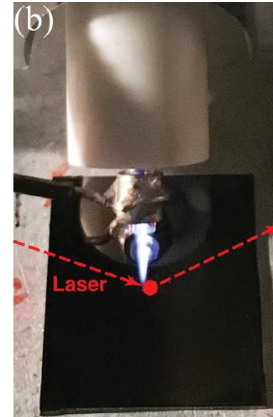


TABLE VI. Obtained etching probability (γ) for different surface loss coefficients (β).

| Species | β | γ |
|-----------------|-----------|------------------------------------|
| O [•] | 10^{-4} | $(1.9 \pm 0.1) \times 10^{-5}$ |
| | 10^{-3} | $(3.2 \pm 0.2) \times 10^{-5}$ |
| | 10^{-2} | $(1.4 \pm 0.2) \times 10^{-4}$ |
| H [•] | 10^{-5} | $< 8.3 \times 10^{-6}$ |
| | 10^{-3} | $< 1.8 \times 10^{-5}$ |
| OH [•] | 10^{-3} | $(2.8 \pm 0.1) \times 10^{-3}$ |
| | 10^{-2} | $(5.750 \pm 0.001) \times 10^{-3}$ |
| | 10^{-1} | $(3.5 \pm 0.1) \times 10^{-2}$ |



Luan et al, J. Phys. D: Appl. Phys. 50 (2017) 03LT02

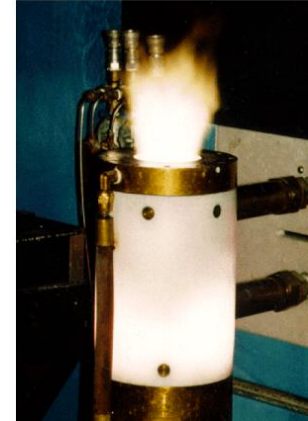
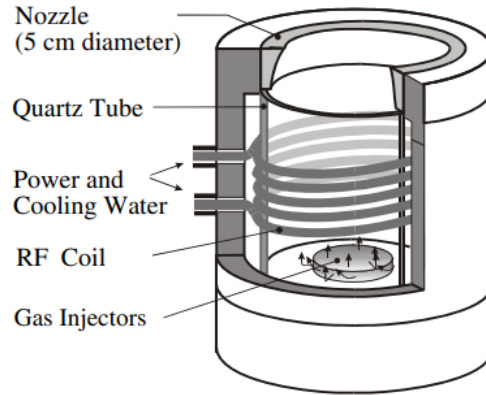
Kondeti et al, J. Vac. Sci. Technol. A 38(3)

Using plasma to modify surface properties of polymers:
Improving adhesion, printing and biocompatibility



Non-equilibrium Flows during Earth Atmospheric Reentry

Plasma Torch Facility at Ecole Centrale Paris



- Earth reentry occurs at hypersonic velocities: $5\text{-}20 \text{ km.s}^{-1}$
- Radiative fluxes from the shock-produced plasma account for up to 50% of the total heat encountered by a spacecraft during reentry
- The plasma generated is under non-equilibrium conditions (strong dissociation occurs)
- Designing effective thermal protective systems (TPS) require accurate quantification of these radiative fluxes
- Experiments performed in ground facilities use plasma torches and arc jet plasmas

MacDonald et al, J. Thermophys. Heat Trans 29.1 (2015)



Summary

- LT plasmas are everywhere around us
- They enable many of our modern technologies
- LT plasma physics a multidisciplinary field
- Their high non-equilibrium feature provides an almost infinite richness
- LT plasmas are relatively easy to generate in the lab. This leads to the research field being exciting and fast-paced
- Ongoing work involves theory, modeling, computational and experimental efforts
- **Come join us!**





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